

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Chih-Chien Liu, et al.

Serial No: 09/546,174

Filed: April 11, 2000

For: High Density Plasma Chemical Vapor Deposition  
Process

Art Unit: 1711

Confirmation No. 4793

Examiner: Sergent, Rabon A.

CERTIFICATE OF ELECTRONIC TRANSMISSION

Date of Transmission: December 20, 2007

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Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

I hereby certify that

- Revocation of Power of Attorney;
- New Power of Attorney and Correspondence Address Indication Form;
- Petition for Extension of Time (three months);
- Response to Office Action;
- authorization to charge Deposit Account the extension fee of \$1,050.00 and any deficiency of fees.

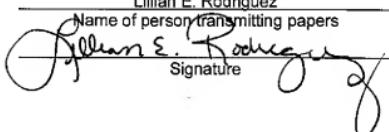
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